

# Jongpil JEONG

Master student

Dept. of Creative Informatics at CSSE

Kyushu Institute of Technology

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## EDUCATION

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### Kyushu Institute of Technology

Master of Engineering in Dept. of Creative Informatics

Graduate School of Computer Science and Systems Engineering

Thesis: "Visibility Restoration under Harsh Conditions using Adaptive Removal via Mask for Scatter (ARMS)"

Advisor: Prof. Min-Chul Lee

Iizuka, Fukuoka, Japan

Apr. 2024 — Mar. 2026(Expected)

Cumulative GPA:3.02/4.00

### Dong-A University

Bachelor of Engineering in Dept. of Electronics Engineering

College of Engineering

(Top 10%; 156 credits completed / 150 required)

Recipient of Academic Excellence Scholarships (5 semesters)

Busan, Korea

Mar. 2018 — Feb. 2024

Cumulative GPA:3.91/4.50

## RESEARCH INTERESTS

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Image signal processing & Computer vision

Biomedical imaging system

Enhancement visibility via scattering media removal

Deep Learning for signal processing.

## SKILLS

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**Languages** Korean (Native), English (OPIc IH), Japanese (Intermediate)

**Programming** C/C++, Python, MATLAB

**Libraries** PyTorch, TensorFlow, OpenCV, Qt, Pandas, NumPy, SciPy, Plotly

**Tools / OS** L<sup>A</sup>T<sub>E</sub>X, Digit Cam, Spinnaker SDK, Pylon SDK, Git, Blender

## RESEARCH PROJECTS

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### Image processing techniques for visualizing poor-visibility scenes under scattering media

Fukuoka, Japan

- *Research Assistant*

Apr. 2024 — Mar. 2027 (Expected)

- Led the development of the Adaptive Removal via Mask for Scatter (ARMS) algorithm to enhance visibility in images degraded by scattering media.
- Resulted in multiple patent applications, including international patents (PCT), protecting the core technology and methodology.

- Grant number: 24K01120 (Funded by KAKEN, JSPS, PI:Prof. M.-C. Lee)

### Development of AR rescue support system for disaster sites with poor visibility using optical signal processing and deep learning

Fukuoka, Tokyo, Japan

May. 2024 — Mar. 2025 (Expected)

- *Research Assistant*

- Designing and optimizing algorithms based on the ARMS to effectively remove non-uniform scattering media.
- Currently working on embedding and optimizing the algorithm for real-time processing on the Microprocessor.

- Grant number: JPJ000255 (Funded by Fire and Disaster Management Agency of Japan, PI:Prof. M.-C. Lee)
- Grant type: Consigned research

### Development of a 360-degree Digital Holographic Microscope (DHM) for 3D object profiling

Fukuoka, Japan

- *Research Assistant*

Apr. 2024 — Mar. 2025

- Statistical approach implemented to mitigate phase error and denoise 3D profile reconstructions.
- Applied a Kalman filter to suppress noise originating from the DC term in the Fourier domain.

- Grant number: 23K19964 (Funded by KAKEN, JSPS, PI:Dr. H.-W. Kim)

**Development of pre-hatching sex determination technology for chickens** Fukuoka, Gifu, Niigata, Ibaraki, Japan

- *Research Assistant*

Apr. 2024 — Nov. 2024

- Developed the core algorithm for high accuracy and efficiency.
- Led the end-to-end development of core algorithm, achieving improvement in accuracy from **56%** to **87%** over previous methods.
- Designed and implemented a Graphic User Interface (GUI) to streamline user interaction.
- Created and packaged the necessary installer for seamless program distribution and development.
- Domestic patent pending (Japan) in collaboration with a private industry partner and National Agriculture and Food Research Organization (**NARO**).

- Grant type: Joint Research with NARO and a private industry partner (Funded by a private industry partner under NDA, PI:Prof. M.-C. Lee)

## PUBLICATIONS

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### Journal

- [1] **J. Jeong**, and M.-C. Lee, “Scattering Medium Removal Using Adaptive Masks for Scatter in the Spatial Frequency Domain,” *IEEE Access*, vol. 13, pp. 72769–72777, 2025.  
DOI:10.1109/ACCESS.2025.3563369

### Conference

- [1] Y. Takahashi, **J. Jeong**, M. Cho, and M.-C. Lee, “A research on scattering media removal and photon estimation using COLANoPS,” *Proc. ICCAS 2025*, (IEEE), Incheon, Korea.  
DOI:10.23919/ICCAS66577.2025.11301366
- [2] **J. Jeong**, M. Cho, and M.-C. Lee, “Advanced scattering media removal by modified ARMS and restoration of color information,” *Proc. ICMV 2025*, (SPIE), Paris, France. (In proceedings).  
- Best Poster Presentation Award
- [3] S. Song, **J. Jeong**, M. Cho, and M.-C. Lee, “Single Haze Removal Method using Peplography,” *Proc. ICMV 2025*, (SPIE), Paris, France. (In proceedings).
- [4] **J. Jeong**, M. Cho, and M.-C. Lee, “Scattering media removal under the harsh conditions using adaptive removal via mask for scatter,” *Proc. ITC-CSCC 2025*, (IEEE), Seoul, Korea.  
DOI:10.1109/ITC-CSCC66376.2025.11137793
- [5] K. Nakamura, **J. Jeong**, M. Cho, and M.-C. Lee, “Adaptive Optimization of Kalman Filtering in Digital Holographic Microscopy for Improved Noise Reduction,” *Proc. ITC-CSCC 2025*, (IEEE), Seoul, Korea.  
DOI:10.1109/ITC-CSCC66376.2025.11137616
- [6] S. Kim, **J. Jeong**, M. Cho, and M.-C. Lee, “Advanced double random phase encryption for simultaneous two primary data,” *Proc. ITC-CSCC 2025*, (IEEE), Seoul, Korea.  
DOI:10.1109/ITC-CSCC66376.2025.11137702
- [7] T. Ono, **J. Jeong**, H.-W. Kim, M. Cho, and M.-C. Lee, “Kalman filtering optimization in digital holographic microscopy (DHM),” *Proc. ICCAS 2024*, (IEEE), Jeju, Korea.  
DOI:10.23919/ICCAS63016.2024.10773243
- [8] **J. Jeong**, H.-W. Kim, M. Cho, and M.-C. Lee, “A study of noise reduction algorithm using statistical optimization in digital holographic microscopy,” *Proc. JCSSE 2024*, (IEEE), Phuket, Thailand.  
DOI:10.1109/JCSSE61278.2024.10613728

### Patents

#### International Patents (PCT)

- [1] M.-C. Lee and **J. Jeong**,  
“Image processing apparatus, image processing method, and image processing program,” Pending  
PCT Patent Reference No. PCT/JP2025/037681

#### Domestic Patents

Japan

- [1] M. Kamide, O. Shiba, K. Ozawa, T. Nakaya, M.-C. Lee, **J. Jeong**, and T. Tagami,  
“Sex identification service provision system and sex identification service provision method,” Sep. 18, 2025  
Japanese Patent Application No. 2025-154965.

- [2] M.-C. Lee and **J. Jeong**,  
“Image processing apparatus, image processing method, and image processing program,”  
Japanese Patent Application No. 2025-097331. Jun. 10, 2025
- [3] M.-C. Lee and **J. Jeong**,  
“Image processing apparatus, image processing method, and image processing program,”  
Japanese Patent Application No. 2024-214715. Aug. 30, 2024
- \* In accordance with Japanese patent law, these applications are kept confidential and are not publicly disclosed for 18 months following their filing. (Reference)

## Research Experience

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**Computational, Holographic and Optical signal processing Lab.** at Hankyung National University Anseong, Gyeonggi-do, Korea  
Visiting Research Student Jan. 2024 — Feb. 2024  
Advisor: Prof. Myugnjin Cho

**3D Optical Imaging System Lab. at Kyushu Institute of Technology** Fukuoka, Japan  
Short-Term Visiting Researcher (Winter & Summer) Jan. — Feb. & Jul. — Aug. 2023  
Advisor: Prof. Min-Chul Lee

**SoC Design Lab. at Dong-A University** Busan, Korea  
Undergraduate Research Intern Sep. 2022 — Jul. 2023  
Advisor: Prof. Bongsoon Kang

## Awards, Scholarships and Tuition Waivers

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**2025 18th International Conference on Machine Vision** Paris, France

- Best Poster Presentation Award

**Kyushu Institute of Technology** Fukuoka, Japan

- **Waivers from Tuition Fees**
  - 2025, 1<sup>st</sup>/2<sup>nd</sup> semester
  - 2024, 1<sup>st</sup>/2<sup>nd</sup> semester

**Dong-A University** Busan, Korea

- **Academic Excellence Scholarship**
  - 2023, 1<sup>st</sup>/2<sup>nd</sup> semester
  - 2022, 1<sup>st</sup> semester
  - 2021, 2<sup>nd</sup> semester
  - 2018, 2<sup>nd</sup> semester
- **Advisory Professor Scholarship from Dong-A University**
  - 2022, 2<sup>nd</sup> semester
- **Undergraduate Education Assistant Scholarship from Dong-A University**
  - 2023, 1<sup>st</sup>/2<sup>nd</sup> semester
  - 2022, 2<sup>nd</sup> semester

## Relevant Coursework

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**Korea OpenCourseWare (KOCW)** Online, Korea  
Digital Image Processing 2025

**IC Design Education Center (IDEC)** Online, Korea

- Implementation of CNN’s FPGA with Verilog HDL 2024
- Design embedded systems based on FPGA
- Data structure and algorithm

- FreeRTOS porting and utilization through Cortex-M processor
  - MIMO - theory and improvement
  - Stereovision for autonomous driving system
  - Design digital system utilized Verilog
  - IDEC SoC Design Course
  - Neural network hardware accelerator “Architecture”
  - DSP with MATLAB
  - Foundation of CUDA-based GPU Programming
- 2023
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- PLL Design and Jitter Interpretation
  - Foundation of Reinforcement Learning
- 2022

**Korea Advanced Institute of Science and Technology (KAIST)**

Seoul (Hybrid), Korea

- Microdegree from Graduate School of Data Science

2023

**Leadership & Volunteering**

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**Innovation Japan 2025**

Tokyo, Japan

*Student Staff*

Aug. 21 2025 — Aug. 22 2025

**Open Campus 2025** (Iizuka Campus, Kyushu Institute of Technology)

Fukuoka, Japan

*Student Staff*

Jul. 19 2025 — Jul. 20 2025

**International Capstone Design Presentation with Partner Universities**

Fukuoka, Japan

*Participant (Student Delegate)*

Jan. 2025

**International Joint Research Meeting and Seminar**

Kumamoto, Japan

*Participant (Student Delegate)*

Aug. 9 2024 — Aug. 10 2024

**Embedded Systems Lab.**

Busan, Korea

*Leader*

Sep. 2023 — Dec. 2023

- Embedded system design using ATMega128A
- Embedded system control using the I/O ports and potentiometer

**Donga Challenge**

Busan, Korea

*Leader*

Sep. 2023 — Dec. 2023

- Self-directed learning and project-based teamwork initiative
- Teaching basic programming (Python) and data analysis using Pandas and NumPy

**Digital System Lab.**

Busan, Korea

*Leader*

Sep. 2023 — Dec. 2023

- Basic programming (C/C++) and embedded system design using ATMega128A
- Teaching digital logic design and Verilog HDL

**Dong-A Ping-Pong Association (DAPPA)**

Busan, Korea

*President*

Mar. 2021 — Feb. 2022

**Military Service**

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**Republic of Korea Army**

Haman, Gyeongsangnam-do, Korea

*Sergeant, Active Duty Soldier*

Apr. 2019 — Nov. 2020

- Award for Outstanding Army Warrior
  - Certificate of Appointment as Squad Leader
  - Appointment Certificate as Squad Representative Soldier
  - Commendation for Exemplary Soldier
- 2020